

AMENDMENT UNDER 37 C.F.R. § 1.111  
U.S. Application No.: 09/313,184

Sub  
D17  
the area of said negative electrode and the area of said positive electrode differ by at least twofold and said areas are set such that the element resistance measured between the negative and positive electrodes is minimized,

at least one of said negative electrode and said positive electrode is embedded in the solid electrolyte substrate; and

the area ratio of the negative and positive electrodes is such that the element resistance measured between the negative and positive electrodes is 94% or less than the element resistance of the same sensor except in which the negative electrode and the positive electrode have the same area.

Sub  
D2  
30. (Twice amended) A sensor for detecting an amount of a gas, comprising an oxygen-ion conductive solid electrolyte substrate having a flat side, a negative electrode and a positive electrode formed on the same flat side of the substrate so as to pump oxygen from the negative electrode to the positive electrode, and a gas diffusion limiting means for limiting the gas diffusing into the negative electrode,

wherein the ratio of the area of said negative electrode to the area of said positive electrode is set within a range of 2:1 to 5:1 such that the element resistance measured between the negative and positive electrodes is minimized, and

said sensor comprising a circuit for applying an electric potential between said negative and positive electrodes such that a pump current of less than 100 microamperes flows between the negative and positive electrodes when the sensor is used for detecting the amount of a gas, said pump current being a measurement of the amount of gas.

Sub  
D2  
31. (Twice amended) A sensor for detecting an amount of a gas, comprising  
an oxygen-ion conductive solid electrolyte substrate having a flat side, a negative  
electrode and a positive electrode formed on the same flat side of the substrate so as to pump  
oxygen from the negative electrode to the positive electrode, and a gas diffusion limiting means  
for limiting the gas diffusing into the negative electrode,

wherein the ratio of the area of said negative electrode to the area of said positive  
electrode is set within a range of 1:2 to 1:5 such that the element resistance measured between  
the negative and positive electrodes is minimized, and

said sensor comprising a circuit for applying an electric potential between said negative  
and positive electrodes such that a pump current of less than 100 microamperes flows between  
the negative and positive electrodes when the sensor is used to detect the amount of a gas, said  
pump current being a measurement of the amount of gas.

Sub  
D2  
32. (Amended) An oxygen sensor for determining the oxygen concentration of a  
gas, comprising first and second chambers (62, 64) formed between first and second oxygen ion  
conductive cell substrates (66, 68) and first and second electrodes (68a, 68b) formed on the same  
plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall  
of the second chamber (64) and said second electrode (68b) being formed outside of the second  
chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second  
electrode and said areas are set such that the element resistance measured between the negative  
and positive electrodes is minimized, and

the second comprises a circuit for applying an electric potential in the range of 0.2 V to 1.1 V between the first and second electrodes such that a pump current of less than 100 microamperes flows between the first and second electrodes when the sensor is used to determine the concentration of oxygen in a gas, said pump current being a measurement of oxygen concentration.

Sub D2  
33. (Amended) A humidity sensor for determining the humidity of a gas, comprising first and second chambers (62, 64) formed between first and second oxygen ion conductive cell substrates (66, 68) and first and second electrodes (68a, 68b) formed on the same plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall of the second chamber (64) and said second electrode (68b) being formed outside of the second chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second electrode and said areas are set such that the element resistance measured between the negative and positive electrodes is minimized, and

the sensor comprises a circuit for applying an electric potential in the range of 1.1 V to 2.5 V between the second electrodes such that a pump current of less than 10 microamperes flows between the first and second electrodes when the sensor is used to determine the humidity of a gas, said pump current being a measurement of humidity.

34. (Amended) An oxygen sensor for determining the oxygen concentration as a component of a gas containing NO<sub>x</sub>, comprising first and second chambers (62, 64) formed between first and second oxygen ion cell substrates (66, 68) and first and second electrodes (68a,

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68b) formed on the same plane of the second cell substrate (68), said first electrode (68a) being formed on an inside wall of the second chamber (64) and said second electrode (68b) being outside of the second chamber (64),

wherein the area of the first electrode is at least twofold larger than that of the second electrode and said areas are set such that the element resistance measured between the negative and positive electrodes is minimized, and

the sensor comprises a circuit for applying an electric potential in the range of 0.2 V to less than 0.5 V such that a pump current of less than 100 microamperes flows between the first and second electrodes when the sensor is used to determine oxygen concentration as a component of a gas containing NO<sub>x</sub>, said pump current being a measurement of oxygen concentration.